



**SWTEST**

PROBE TODAY, FOR TOMORROW

**2023 CONFERENCE**

# Maximizing CCC and the March to an Unburnable Probe



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FormFactor

June 5 - 7, 2023

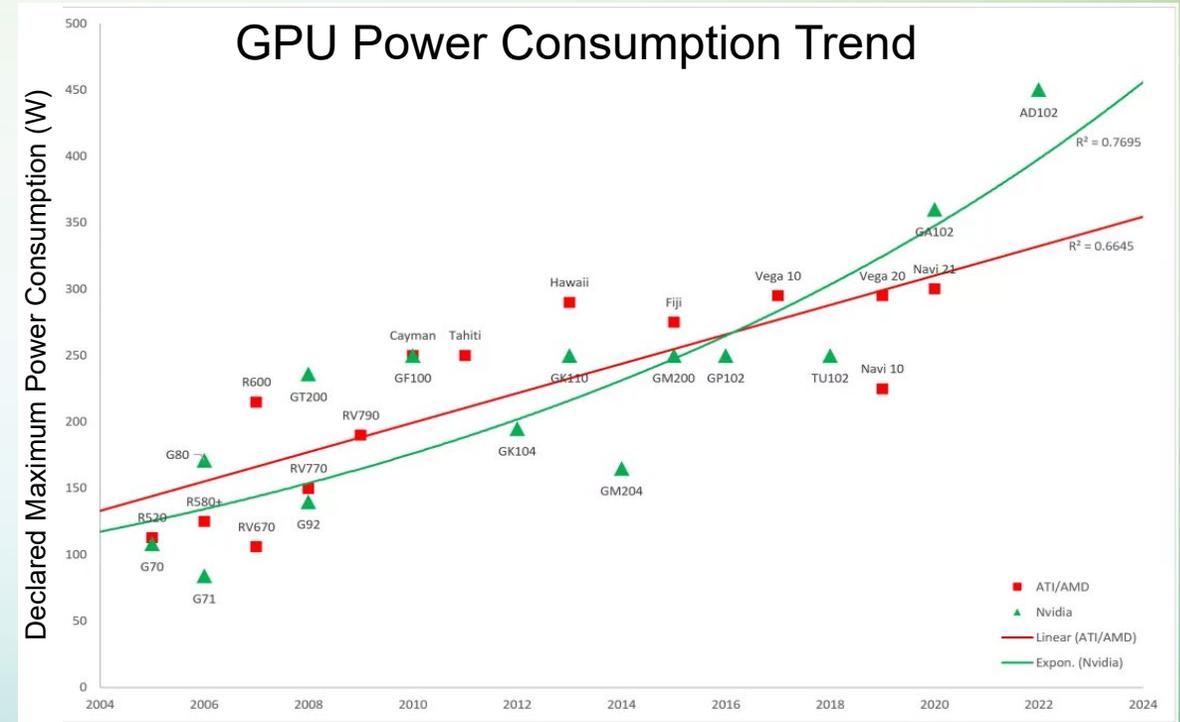
# Agenda

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- **Why Does CCC matter?**
- **Hybrid Probe Review**
- **Next Generation Probe Review**
- **Metallized Guide Plate Review**
- **Maximized CCC Conclusion**

# Industry Trends

- High Performance Compute and GPU applications are marching to 1kW devices (1,000A at 1V)
  - Currently shipping 400A devices today (400W at 1V)
  - Newest HPC devices have >50 Billion Transistors
- New nodes and technology advancements are creating downward pressure on yield
  - Yield drop with each node transition
  - Transitions to more complex digital coms (PAM4) decrease yield
  - Larger die for HPC and GPU applications are lowering wafer yield
- As yields decrease and as device power increases Probe Card capability and CCC must increase



<https://www.techspot.com/article/2540-rise-of-power/>

# CCC Terminology

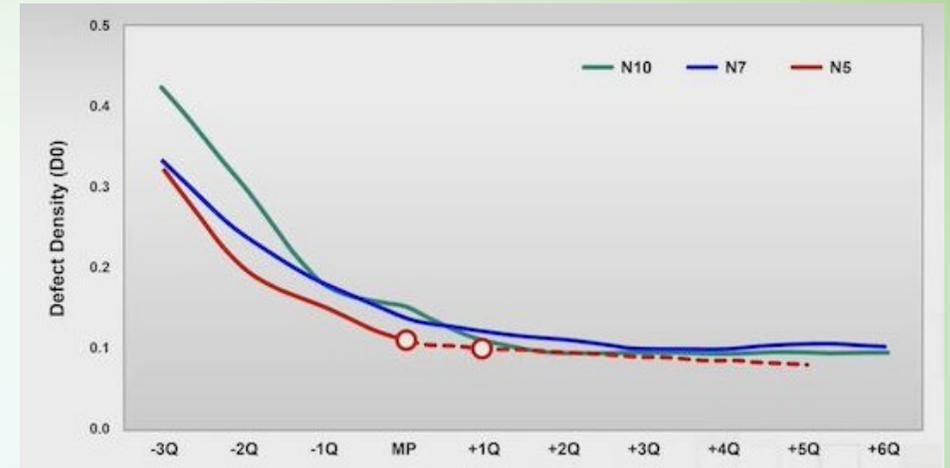
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- **Current Carrying Capability**
  - The amount of current that a probe or spring can withstand before burning or damage occurs
- **ISMI CCC**
  - Current applied where a 20% lower force is observed in a probe (spring)
- **MAC (Maximum Allowable Current)**
  - Current applied where a change in probe force or planarity is first observed
- **ECCC (Effective Current Carrying Capability)**
  - An averaging of total current that a group of probes can withstand before burning occurs

# Why Does CCC Matter?

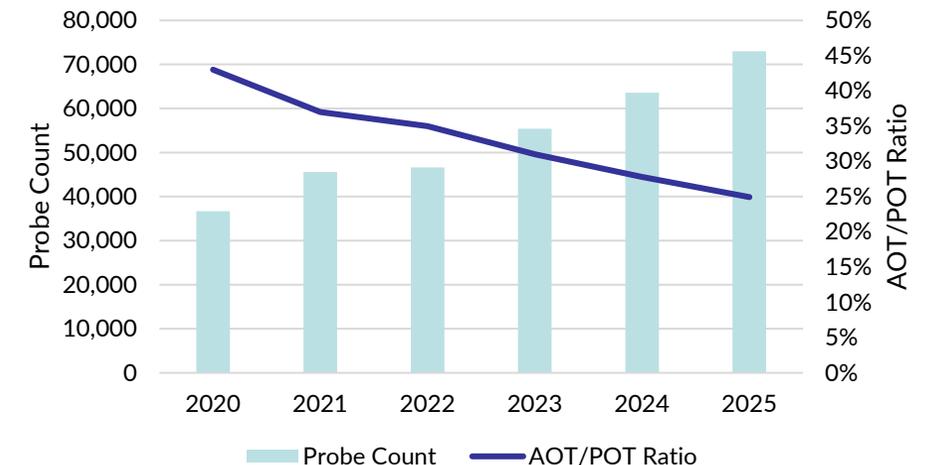
- **Probe Current Carrying Capability prevents probe burning when something goes wrong during wafer testing**
  - Shorts in the DUT
  - Unstable contact between the DUT and Probe card
- **High CCC Probes improves uptime and MTBF as the probe card becomes more robust and resistant to probe burning**

Defect Density over Time by Node



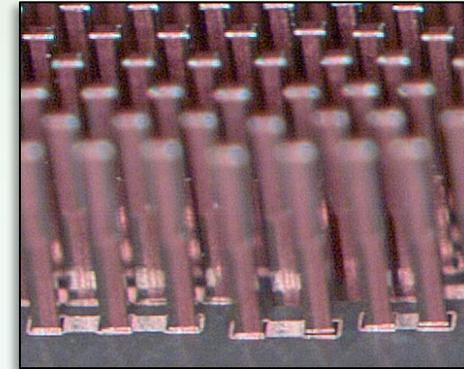
<https://www.anandtech.com/show/16028/better-yield-on-5nm-than-7nm-tsmc-update-on-defect-rates-for-n5>

Mobile AP Probe Count and AOT/POT

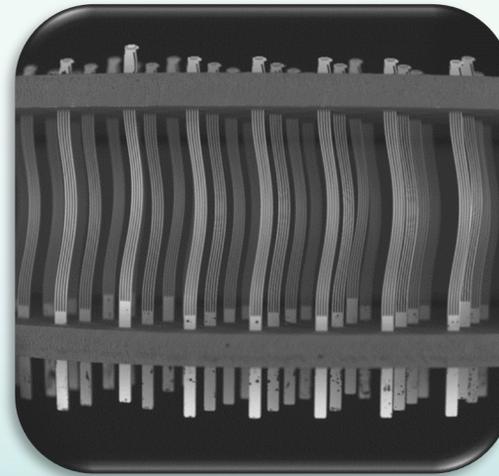


# Methods for Improving CCC

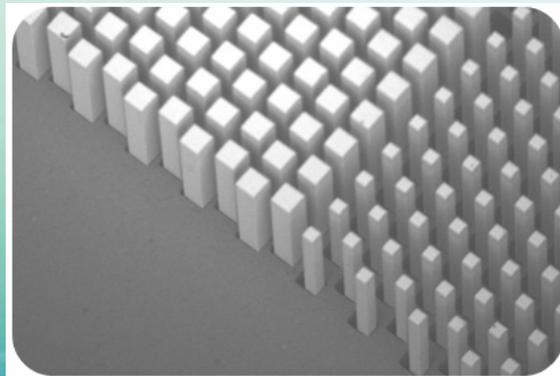
Metallized Guide Plates



Next Generation Probes



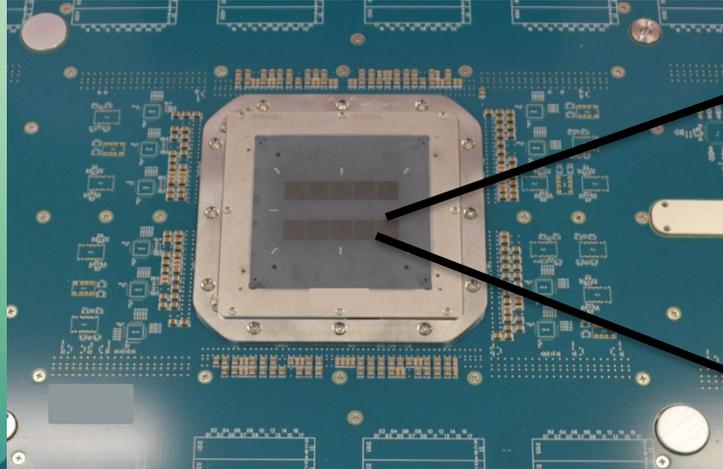
Hybrid Probes



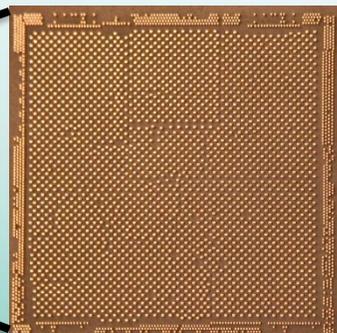
# Hybrid Architecture

- SOCs have PWR/GND in the middle of the Device and I/O in the periphery of the Device
  - PWR/GND typically at  $\geq 150\mu\text{m}$  pitch
    - Can use wider, high CCC probes
  - I/O typically at  $\leq 90\mu\text{m}$  pitch
    - Can use smaller, lower CCC probes
- By combining probe types in the Probe Card the Effective CCC is increased

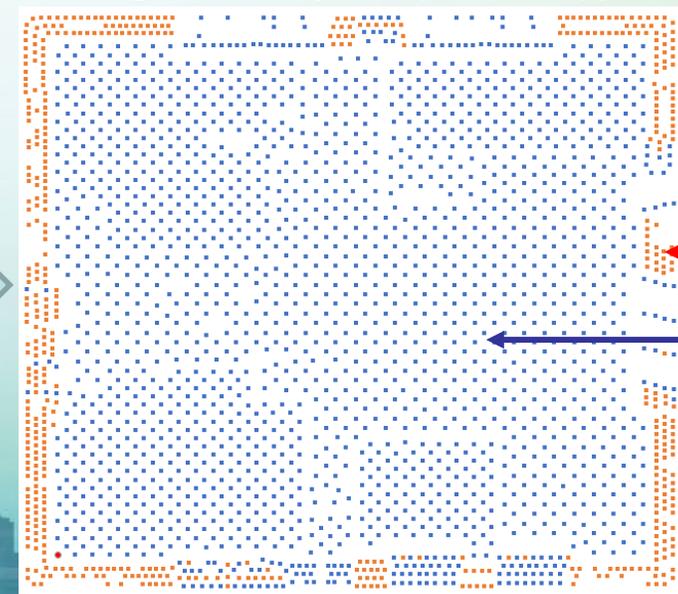
Hybrid Spring Head Probe Card - V93K DD



DUT Zoomed In



Single DUT Layout by Probe Type



Tighter Pitch Probes  
with lower CCC

Wider Pitch Probes  
with Higher CCC

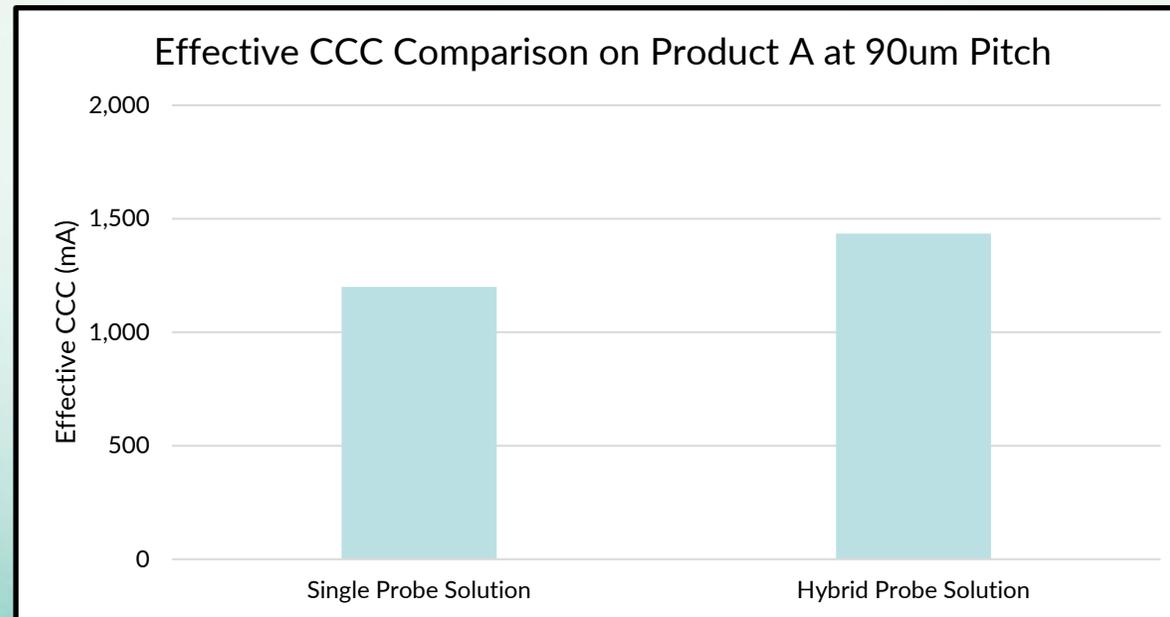
## Hybrid Increasing Available CCC

- **FFI Hybrid probe technology increases probe card available CCC**
  - combining tight pitch low CCC probes and wide pitch High CCC probes in the same design
- **Product A as a test case**
  - Min Pitch = 90um
  - Requires MF100F for 90um pitch with CCC of 1,200 mA
  - If hybrid is used available CCC can be improved by 20% to 1,435 when using MF130/MF100

Product A x8 Hybrid Available CCC Example		
Hybrid Probe Type	MF100F	MF130F
CCC (mA)	1,200	1,500
Probe Count	4,216	15,248
Total CCC (mA)	5,059,200	22,872,000
Total Probe Card Available CCC (mA)	1,435	
% Improvement over Single Probe (MF100)	20%	

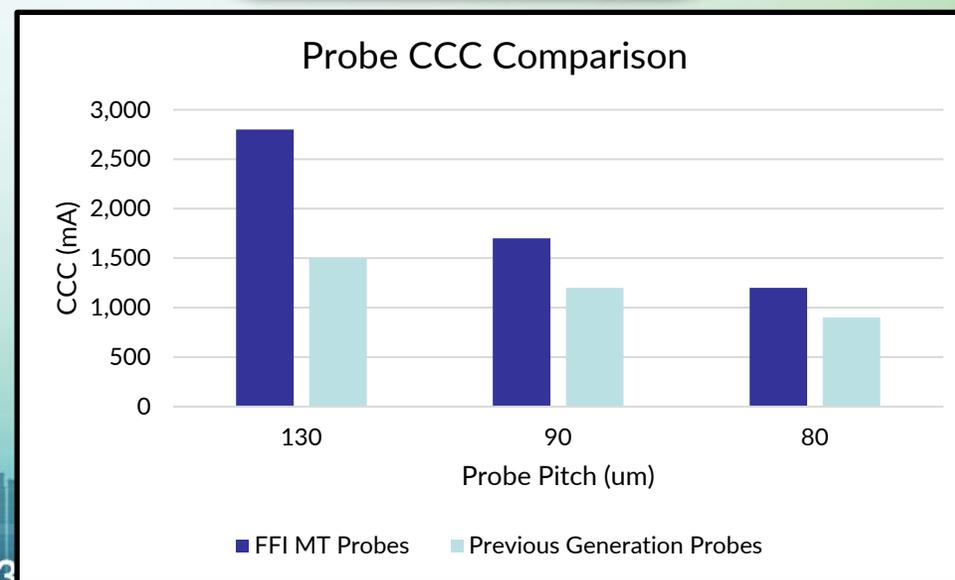
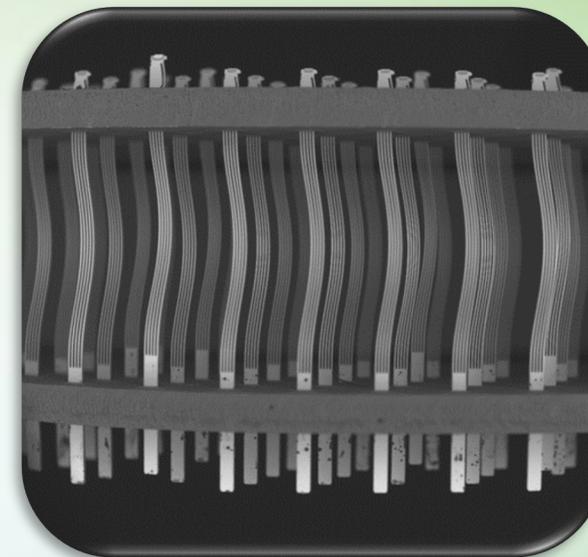
# Maximizing Effective CCC

- Hybrid probes provide 20% higher effective CCC relative to single probe solutions



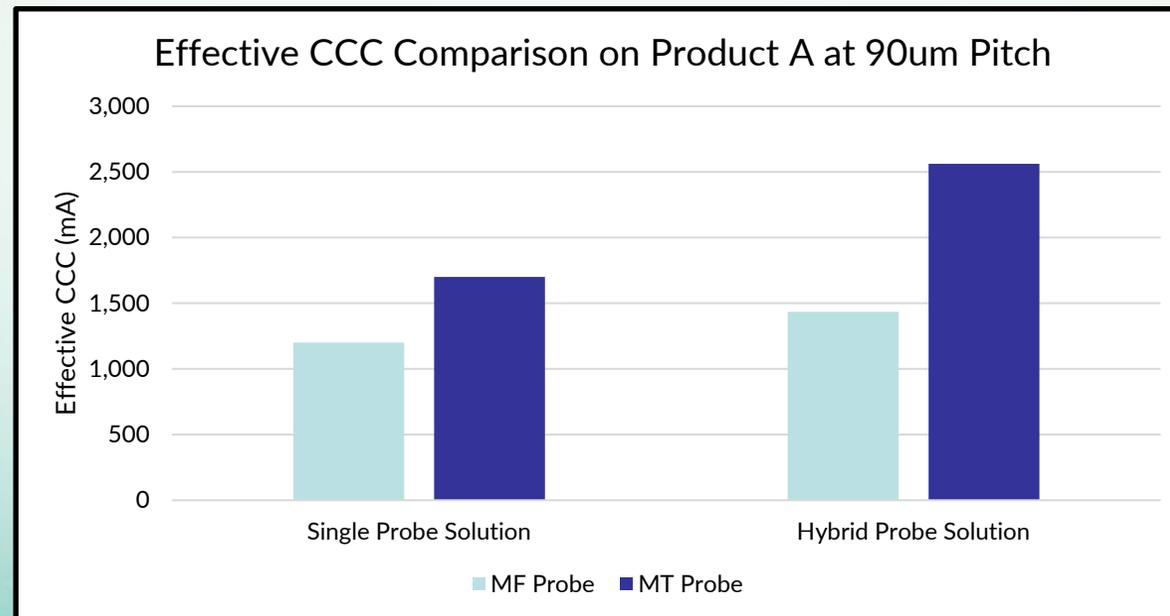
## FFI MT Probe

- MT next generation probes provide **>50% improved CCC** over current gen. MEMS probes
- **Higher speed** performance with shorter probe length.
- **Hybrid** compatible MT probe family to further enhance CCC and high-speed capability.
- **Metallized Guide Plate** can further increase effective CCC to **>3A**

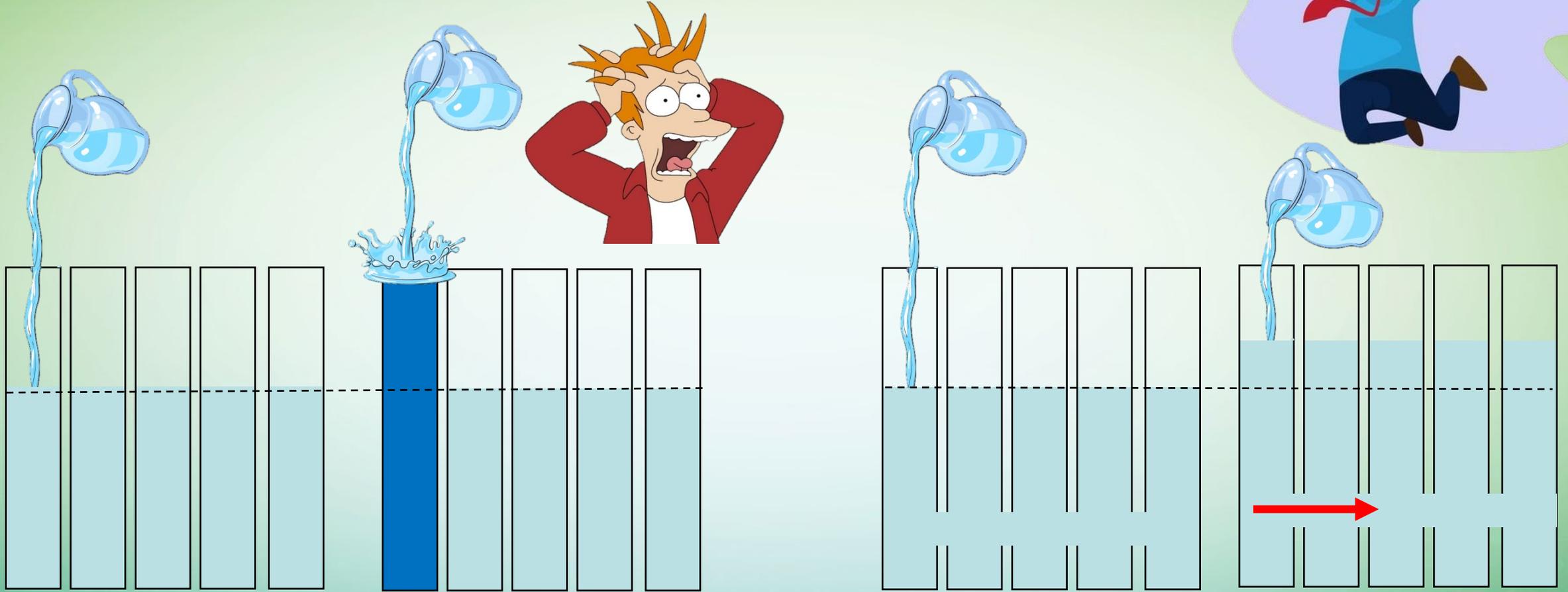


# Maximizing Effective CCC

- Hybrid probes provide 20% higher effective CCC relative to single probe solutions
- MT Probes provide 42% higher CCC relative to last generation probes
  - 78% improvement when combined with Hybrid



# What is Metalized Guide Plate? (Analogy)



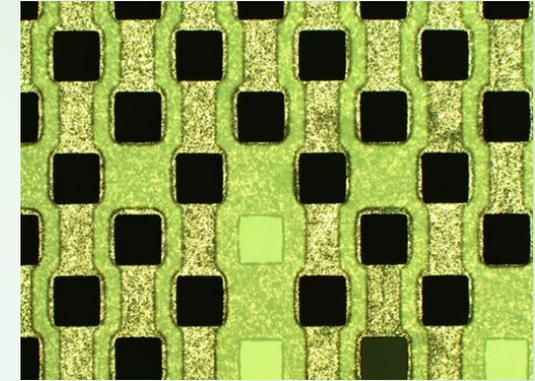
**OVERFLOW!!  
(No MeGP)**

**Distributed  
(MeGP)**

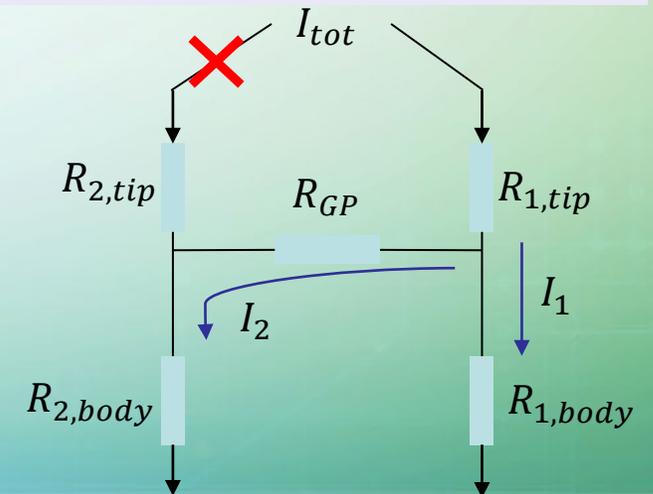
# What is Metallized Guide Plate?

- Metallized Guide Plates (MeGP) connect VDD and GND nets together through metal patterns on the Guide Plate
  - Provides alternative current path when overcurrent events occur
  - Enables Improved Contact with the DUT through alternative current paths

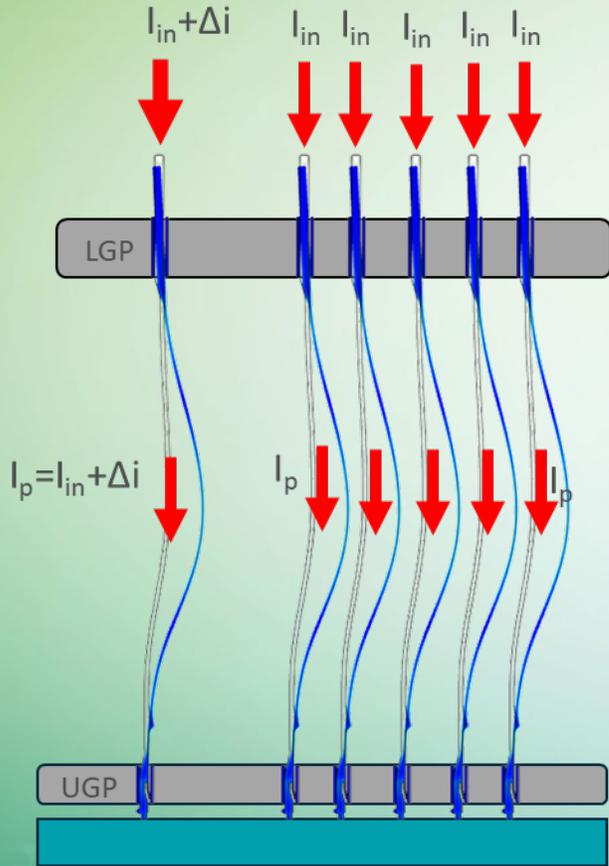
Metallization High Magnification



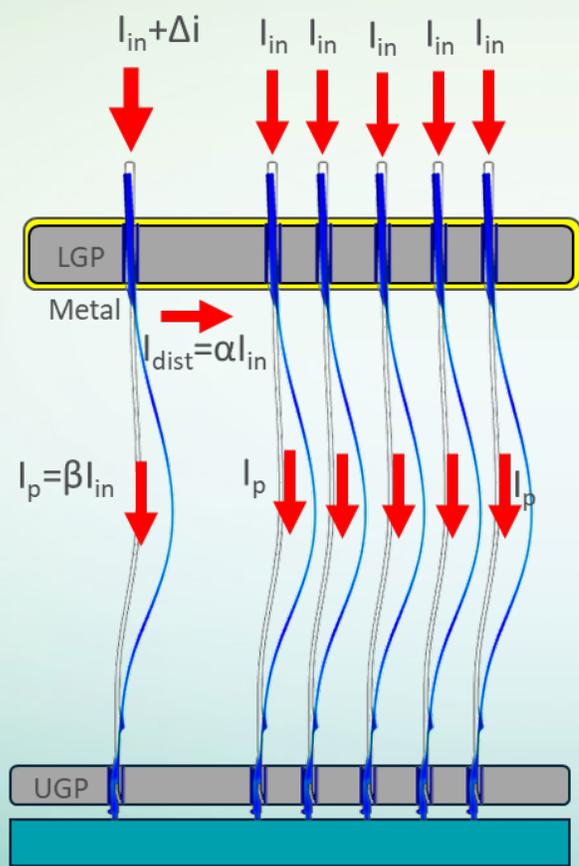
Metallization 2-Probe Circuit



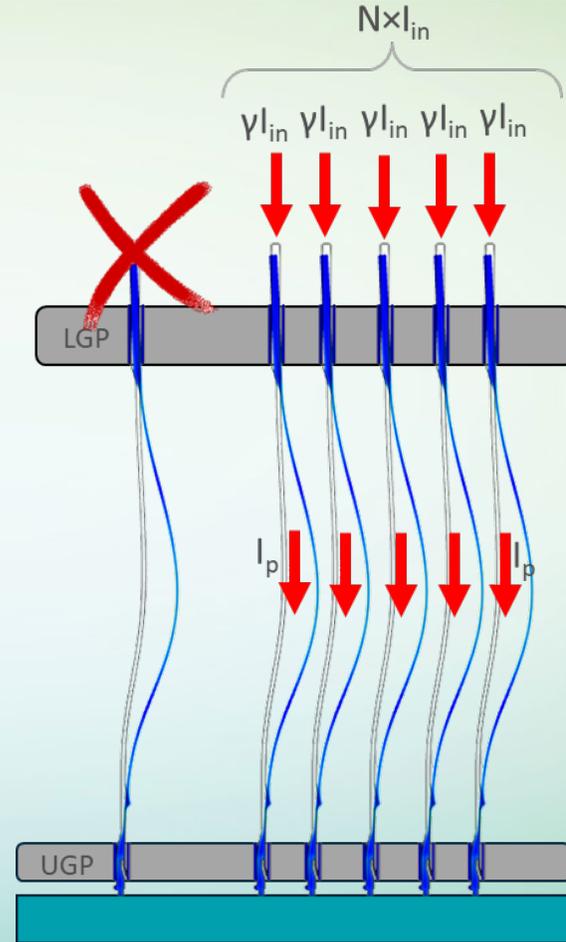
# Examples of how MeGP can help



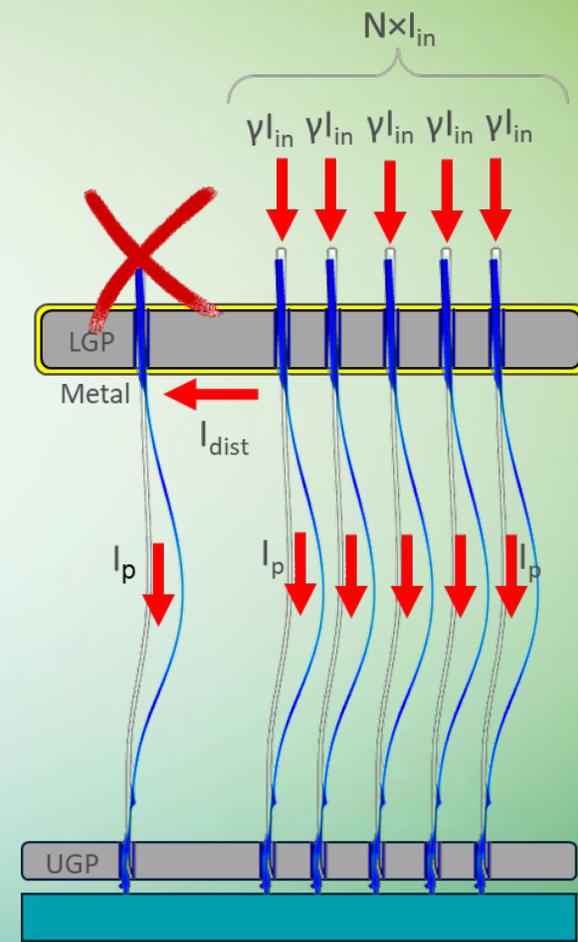
No MeGP



Current Spikes are re-distributed in MeGP case

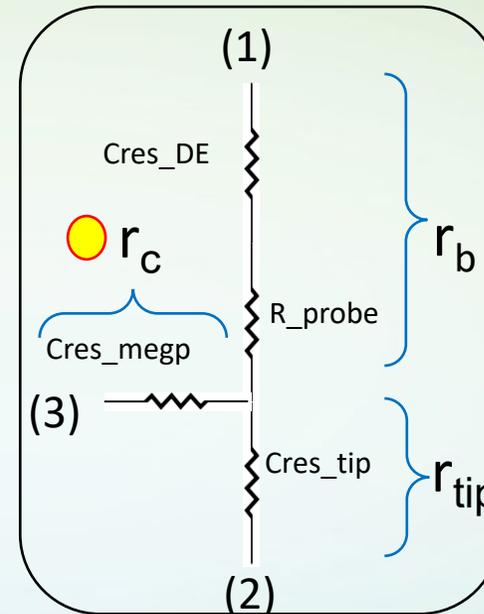
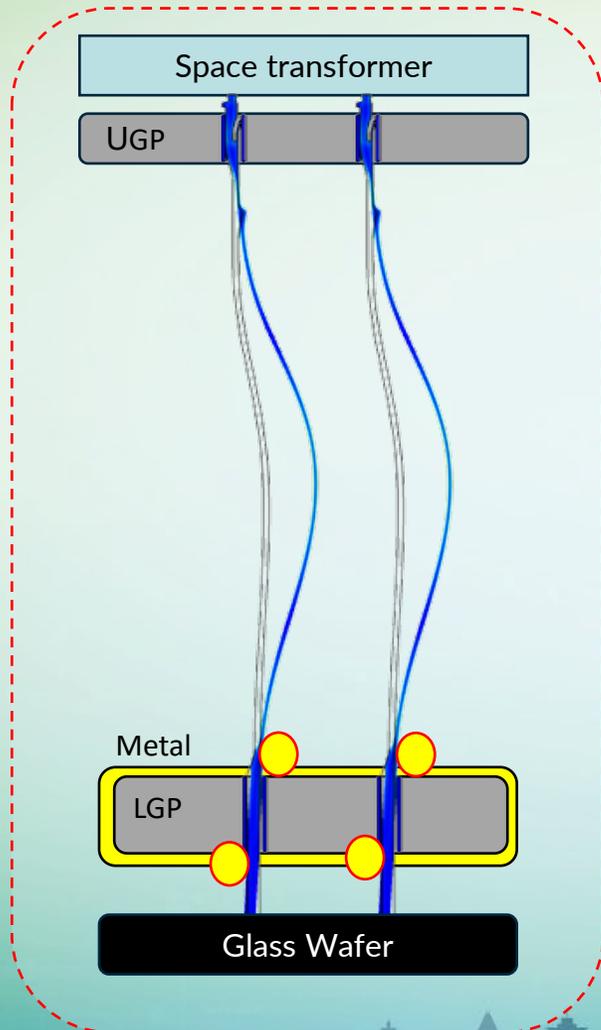


No MeGP



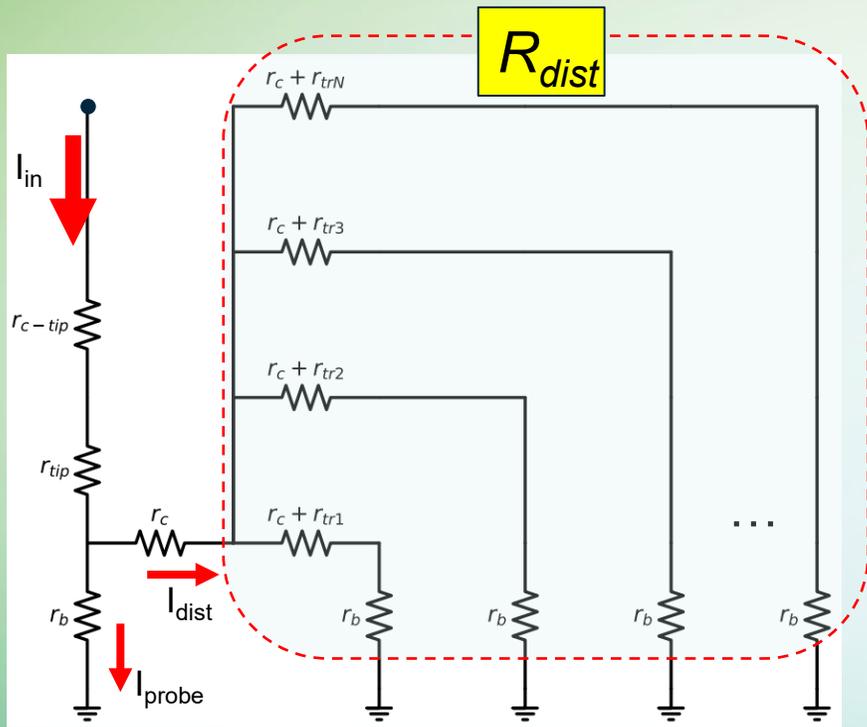
Poor contact or disconnect

# MeGP Technical Terminology



- $r_b$ : Probe body + DE Cres
- $r_c$ : Tip-MeGP Contact resistance
- $r_{tr}$ : Trace resistance

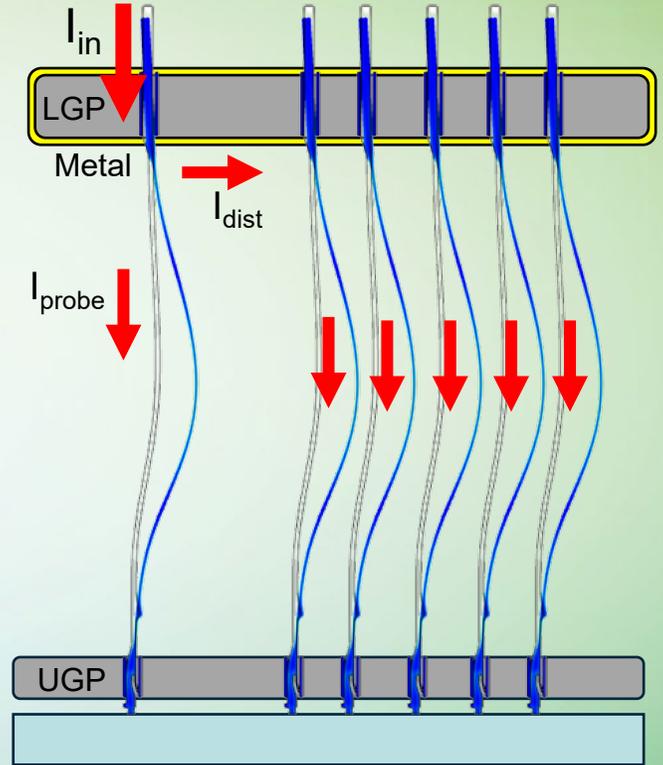
# Generalized MeGP Effective CCC model (building block)



Effective CCC

$$ECCC = I_{probe} \left( 1 + \frac{r_b}{r_c + R_{dist}} \right)$$

amplification factor



$$R_{dist} = \left( \sum_{n=1}^N \frac{1}{r_c + r_{tr(n)} + r_b} \right)^{-1}$$

- $r_b$ : Probe body + DE Cres
- $r_c$ : Tip-MeGP Contact resistance
- $r_{tr}$ : Trace resistance
- N: Number of probes
- $R_{dist}$ : resistance of distributed network

# Effect of trace resistance and number of probes

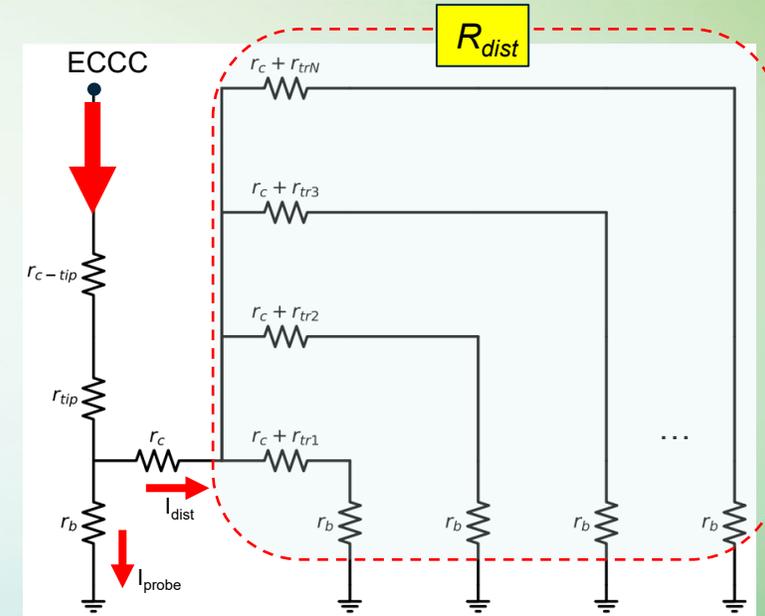
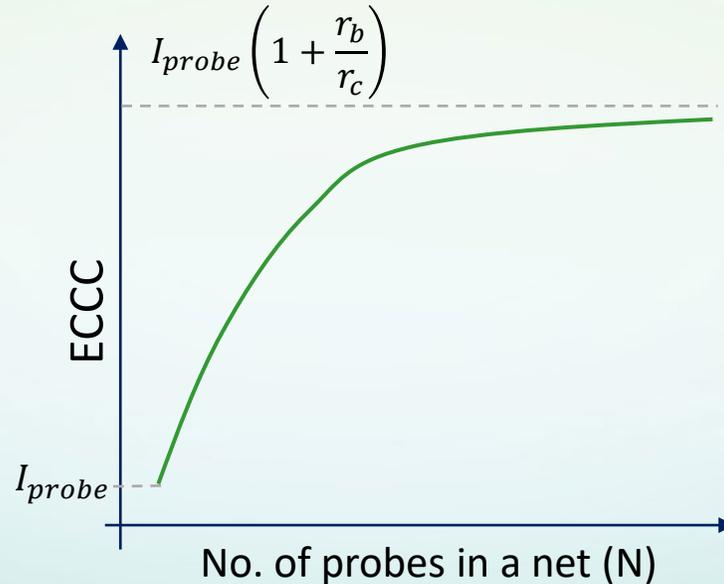
(1) If  $r_{tr} \ll r_c + r_b$ , the CCC will be layout independent, and the general equation reduces to:

$$ECCC_1 = I_{probe} \left( 1 + \frac{r_b}{r_c + \frac{r_c + r_b}{N}} \right)$$

(2) For large gang numbers, N, the equation reduces to:

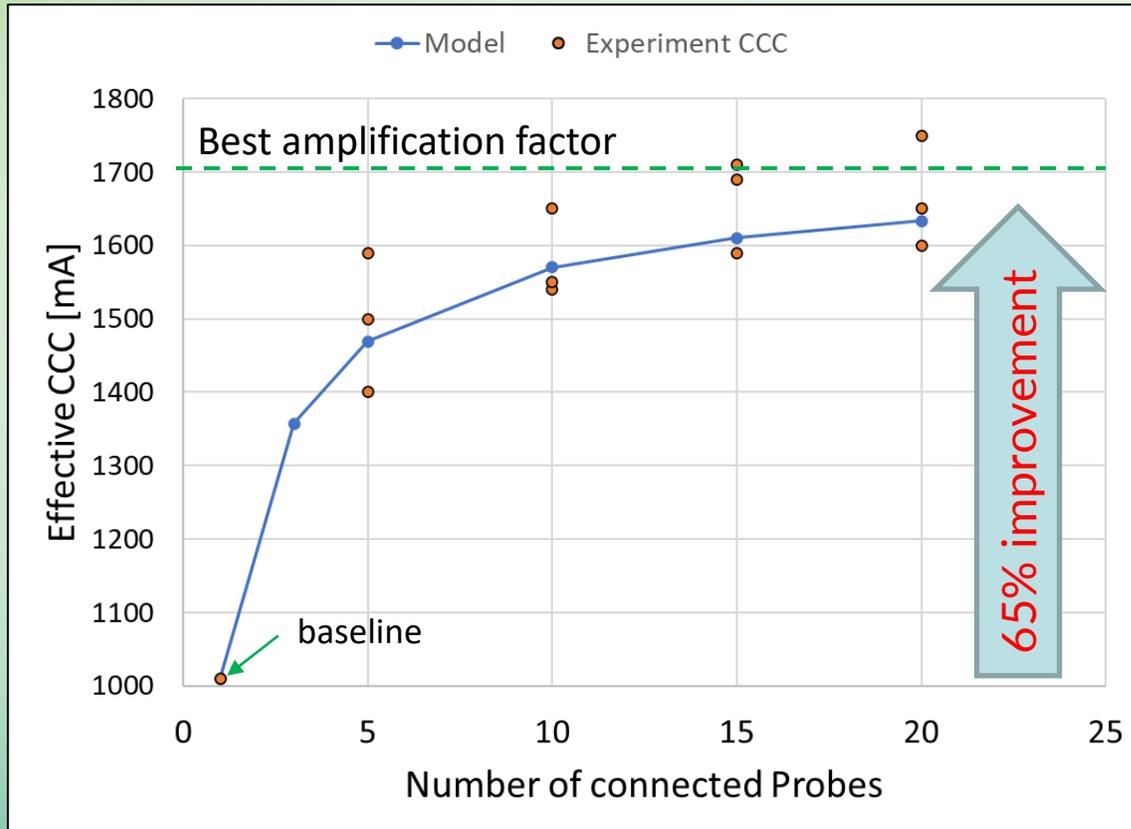
$$ECCC_2 = I_{probe} \left( 1 + \frac{r_b}{r_c} \right)$$

$1 + \frac{r_b}{r_c}$  is the best CCC amplification factor one can get.



$r_b$ : Probe body + DE Cres  
 $r_c$ : Tip-MeGP Contact resistance  
 $r_{tr}$ : Trace resistance  
 $N$ : Number of probes

# Validation using measured CCC and True MeGP CRES data

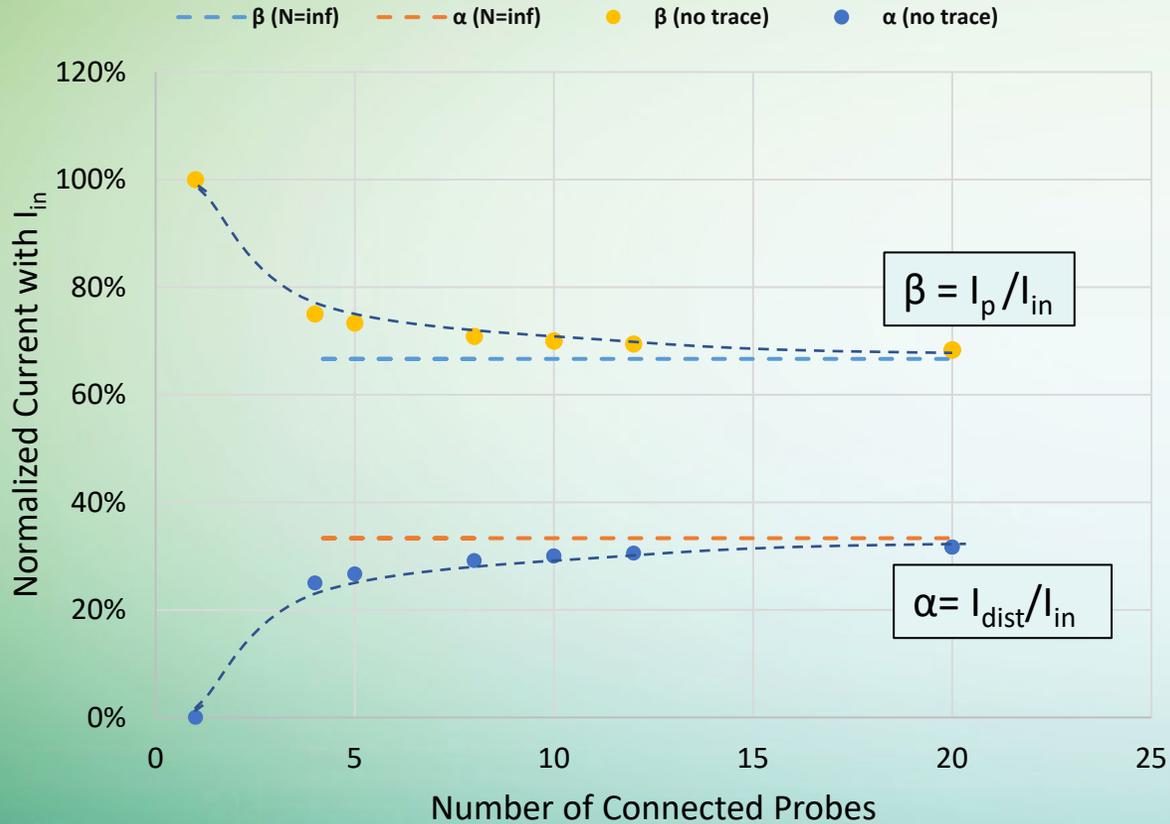


Effective CCC

$$ECCC = I_{probe} \left( 1 + \underbrace{\frac{r_b}{r_c + R_{dist}}}_{\text{amplification factor}} \right)$$

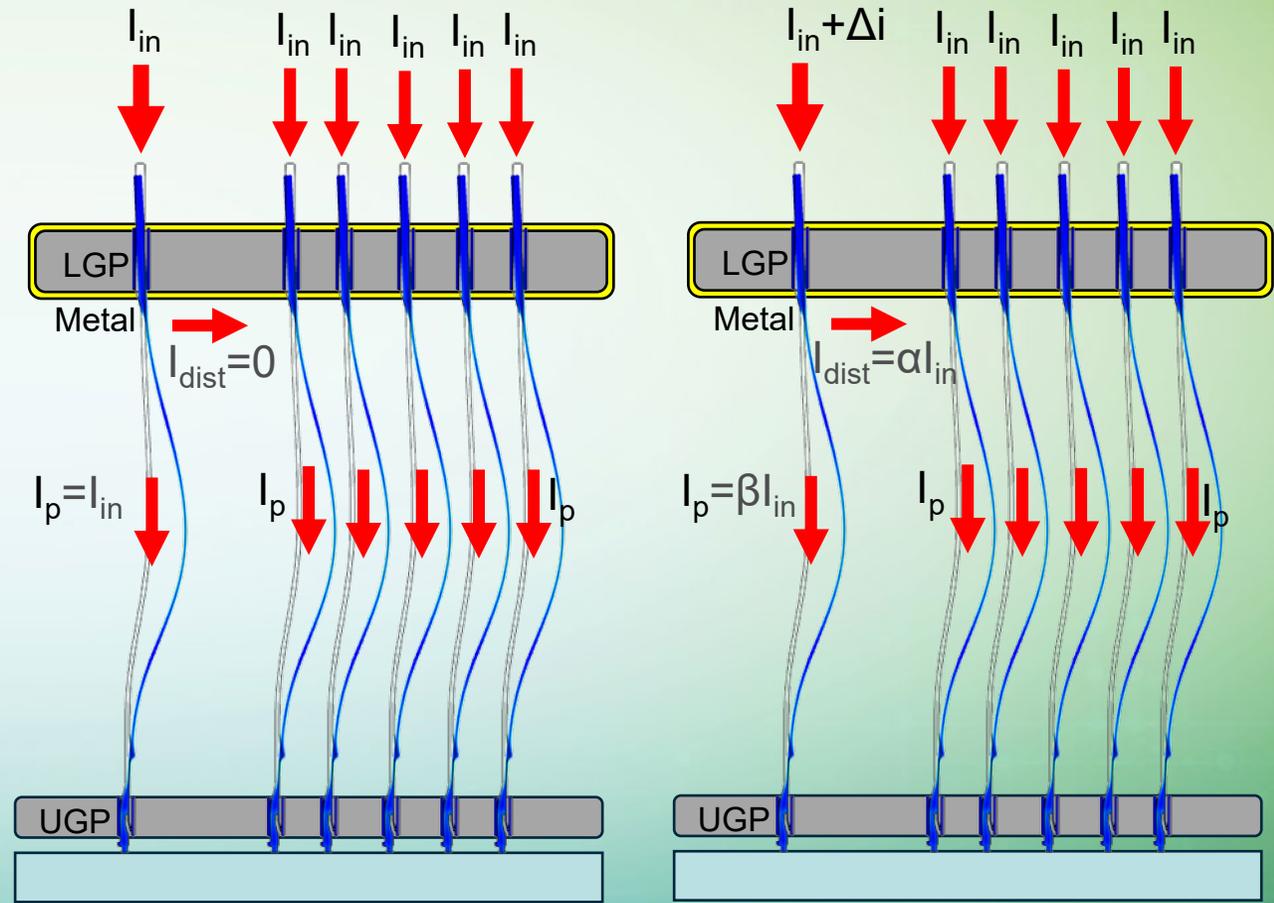
- 10 Excellent agreement between model and experiment was achieved.
- 10 ECCC showed a 65% average improvement for 20 connected probes.

# Model Extension to real cases – Current Spike events



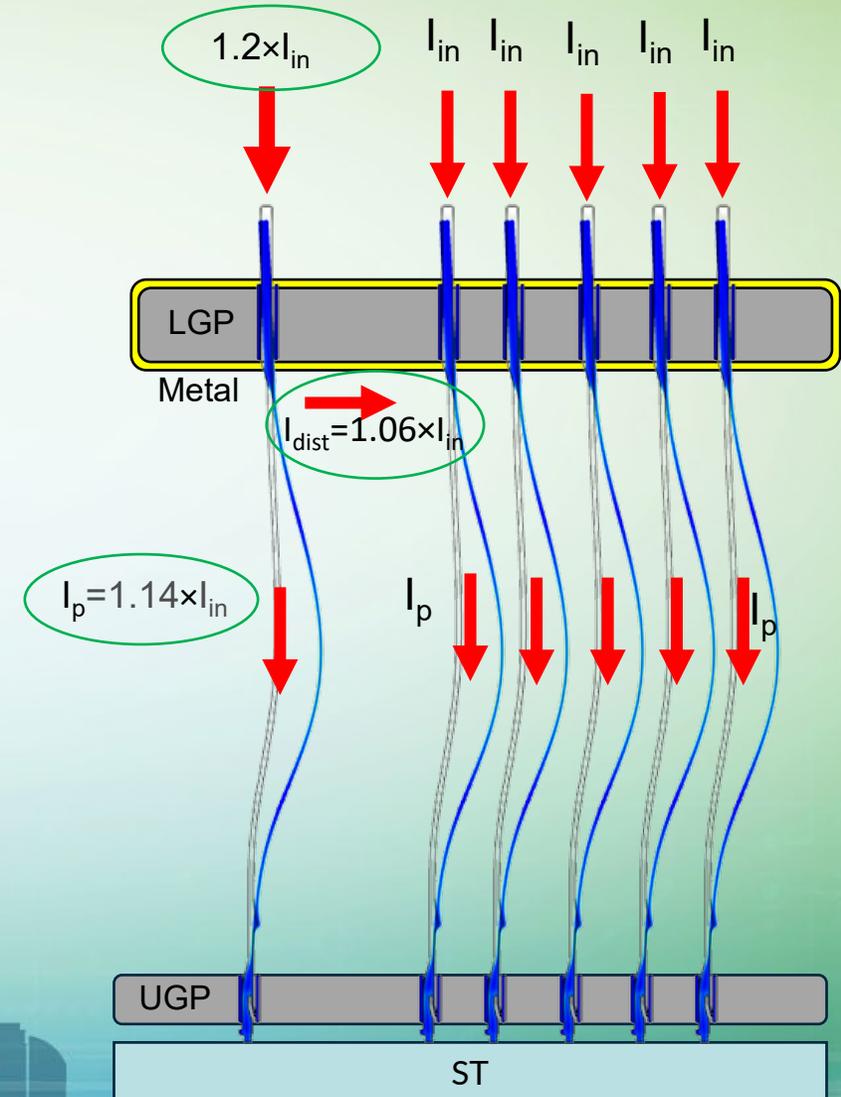
Ideal case with no current variation

Current spike event



# Numerical example

- For a 20-ganged probes with negligible trace resistance,  $\alpha = 32\%$  and  $\beta = 68\%$ .
- A 20% increase in nominal current ( $I_{in}$ ), translates to 6.4% increase in  $I_{dist}$  and 13.6% in  $I_{probe}$ .



# MeGP Design Challenges

- **Challenge: Design of the MeGP is difficult due to the number of nets and probes involved.**
  - A design error could be fatal in the yield of the MeGP leading to shorts from VDD to GND
  - Design complexity could significantly
- **Solution: Automated Design and DFM rule implementation**
  - Eliminates mistakes from manual design
  - Decreases design cycle time to a few hours

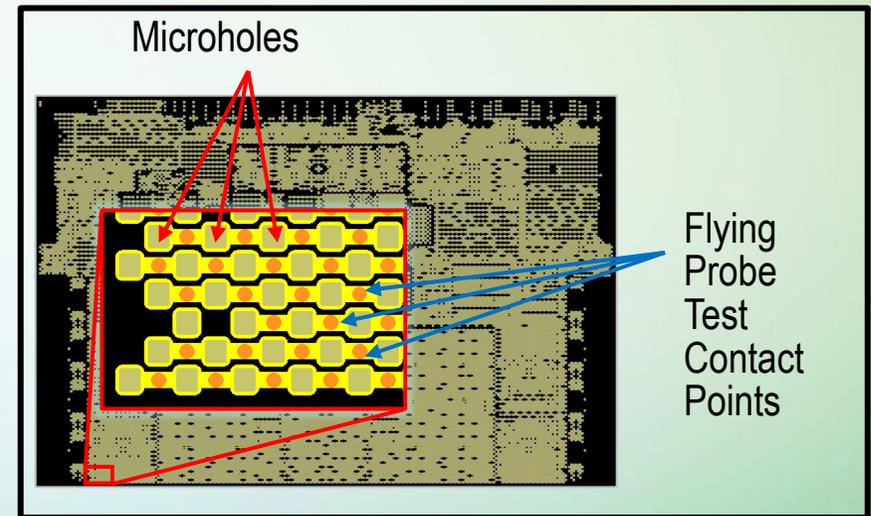
Design Automation Improves Design Cycle Time and Reduces Errors



# MeGP Verification Challenges

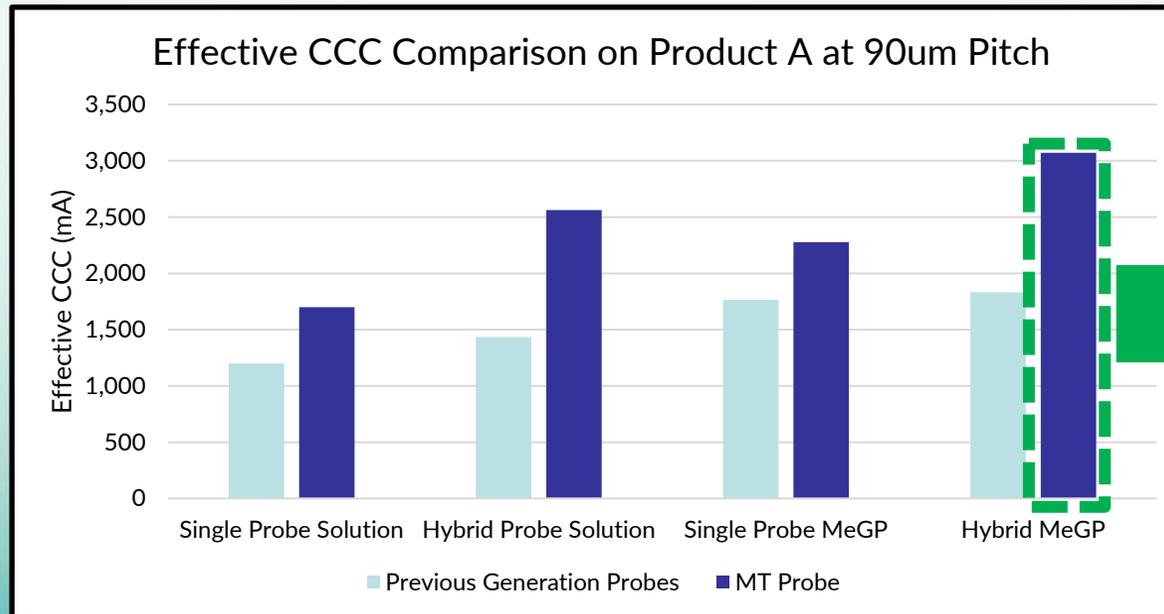
- **Challenge: MeGP needs to be verified for shorts before stitching the probes and completing assembly of the Probe Card**
  - POR process flow verifies electrical continuity with PRVX
    - If short is found the Probe Head would need to be disassembled and fixed
      - Long Cycle times at the last step of the manufacturing process
- **Solution: Implementation of Flying Probe Test after MeGP Plating**
  - Allows rework of GPs if needed
  - Ensures high quality through manufacturing process

Flying Probe Test Contact Points



# Maximizing Effective CCC

- MeGP Improves Effective CCC by 65% depending on the probe architecture
- FFI has achieved the first >3A CCC Probe card at 90um pitch using Next generation MT Probes, Hybrid probes, and Metallized Guide Plate
  - Short Cycle Time and Excellent quality guaranteed through Design Automation and Outgoing Flying Probe Test



MT Hybrid with MeGP provides Best Effective CCC >3A



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**Thank You!!**

A silhouette of a city skyline is visible at the bottom of the slide, with two palm trees on the far left and far right. The skyline includes various buildings and a bridge.

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